

PATENT
Docket No. SJO920010058US1

**IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE**

APPLICANT(S): TSANN LIN

SERIAL No.: 10/066,835

FILING DATE: FEBRUARY 4, 2002

TITLE: IN-SITU OXIDIZED FILMS FOR USE AS GAP LAYERS FOR A SPIN-VALVE
SENSOR AND METHODS OF MANUFACTURE

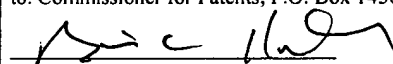
EXAMINER: KEVIN M BERNATZ

GROUP ART UNIT: 1773

ATTY. DKT. No.: SJO920010058US1

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 23, 2004.


Attorney for Applicant

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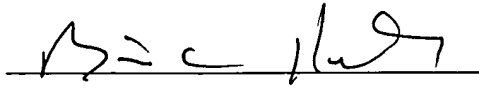
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Sir:

Please send all future correspondence related to the above-referenced patent application to:

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Respectfully Submitted,
Brian C. Kunzler

A handwritten signature in black ink, appearing to read "B. C. Kunzler", is written over a horizontal line.

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